

03500.016133

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAYOSHI MUTA

Application No.: 10/052,450

Filed: January 23, 2002

For: SEMICONDUCTOR DEVICE,
PRODUCTION METHOD
THEREFOR, AND
ELECTROPHOTOGRAPHIC
APPARATUS

Examiner: E. Lee

Group Art Unit: 2815

December 19, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. A copy of each of the listed documents, together with an English-language abstract, is enclosed.

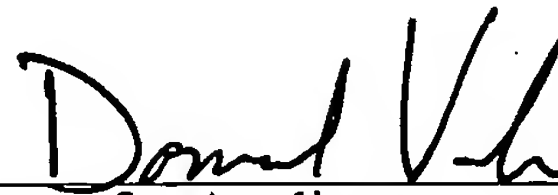
The listed documents were cited in a Search Report in a corresponding Chinese application. (The English-language version of the Search Report contains a typographical error. "JP2002-259803A" should read --JP2000-259803A--.) A copy of the Search Report, which is dated October 10, 2003, is enclosed. In view of this date, it is hereby certified under 37 C.F.R. § 1.97(e) that each item of information in this Information Disclosure Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

The Examiner is urged to study this information in its entirety and to form an independent determination of the materiality of the information to the claimed invention. Additionally, the Examiner is requested to indicate that this information has been considered by initialing the appropriate portion of the Form PTO-1449.

This application has received a final Office Action dated November 20, 2003. Accordingly, this Information Disclosure Statement is filed under 37 C.F.R. §1.97(d) and is accompanied by the \$180.00 fee specified at 37 C.F.R. §1.17(p). Consideration of the information cited herein is accordingly deemed proper, and such action is respectfully requested.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Damond E. Vadnais
Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
DEV/vc

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. 03500.016133		APPLICATION NO. 10/052,450	
		APPLICANT TADAYOSHI MUTA			
		FILING DATE January 23, 2002		GROUP 2815	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	✓	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		1208487 A	02/17/1999	CHINA			Abstract
		2000-259803 A	09/22/2000	JAPAN			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.